

FIG. 1

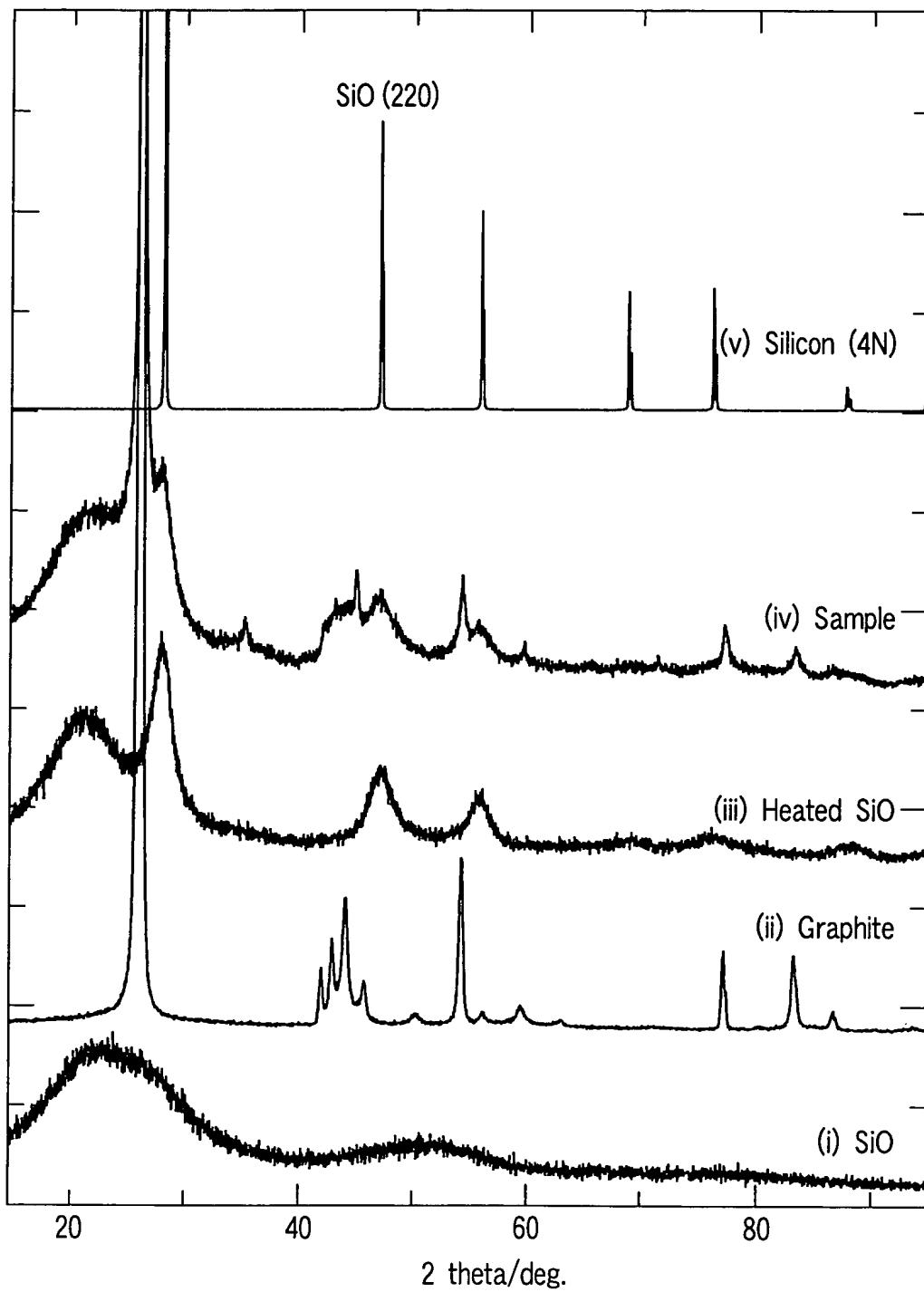


FIG. 2

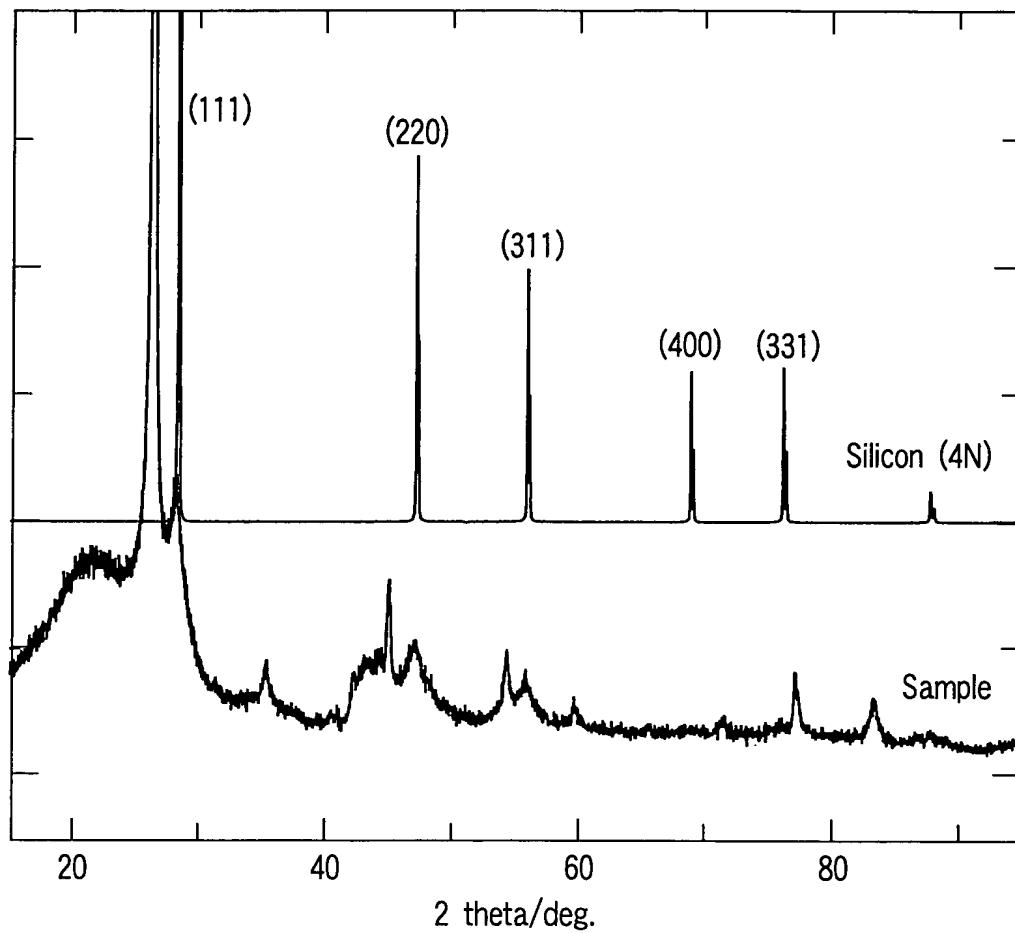
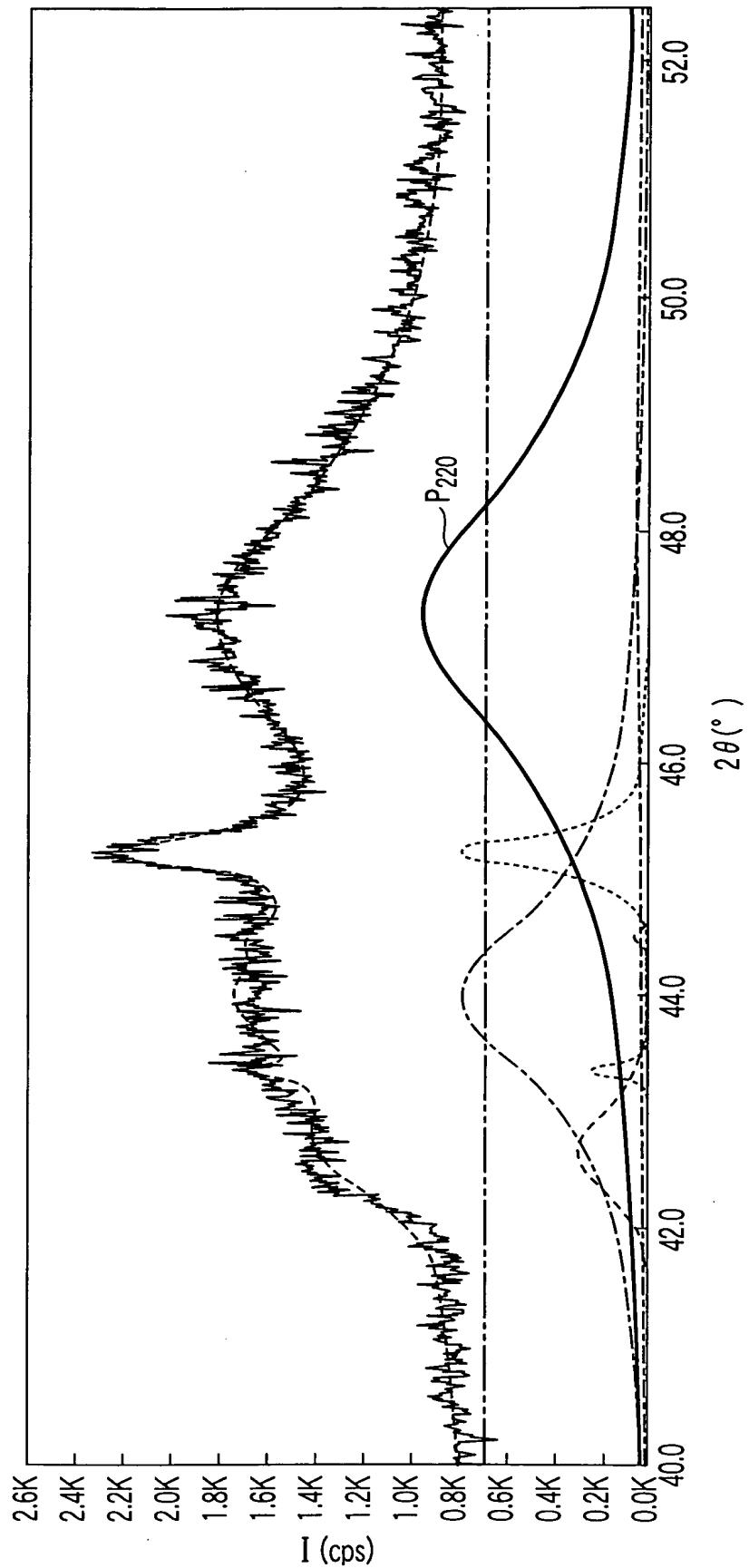


FIG. 3



F | G. 4



FIG. 5

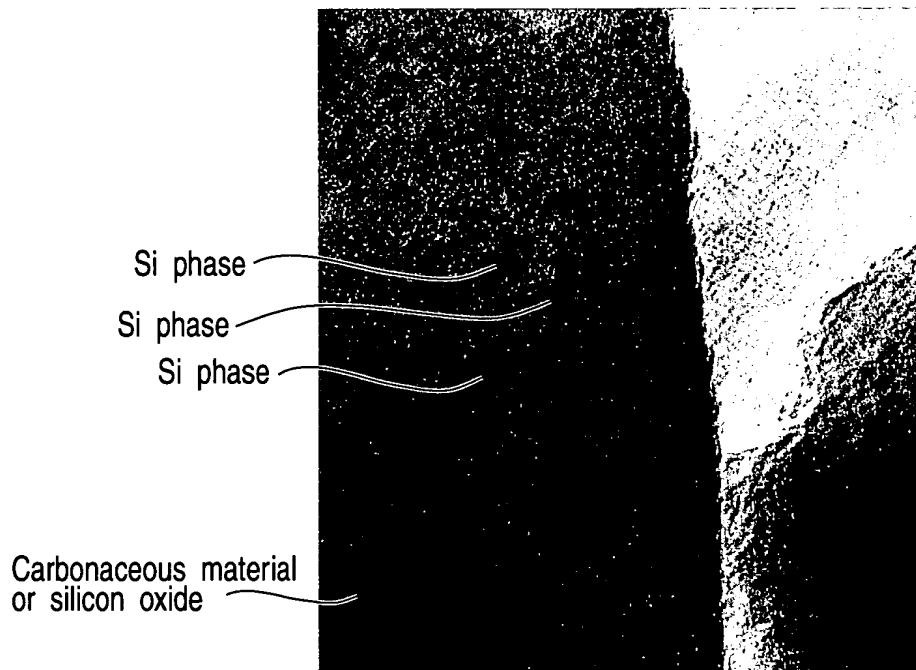


FIG. 6

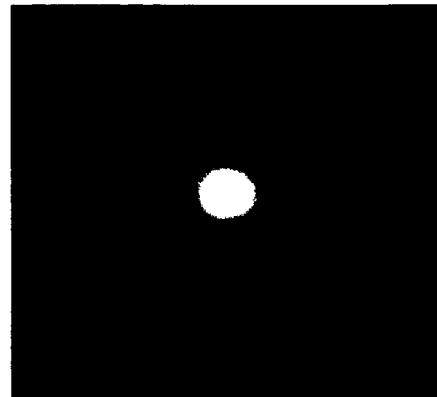


FIG. 7

(c) Electron beam diffraction pattern
Si microcrystal

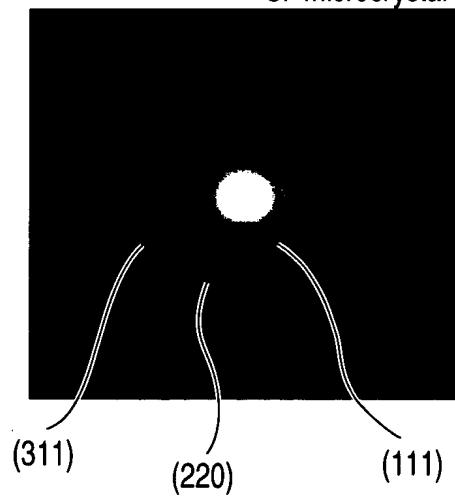
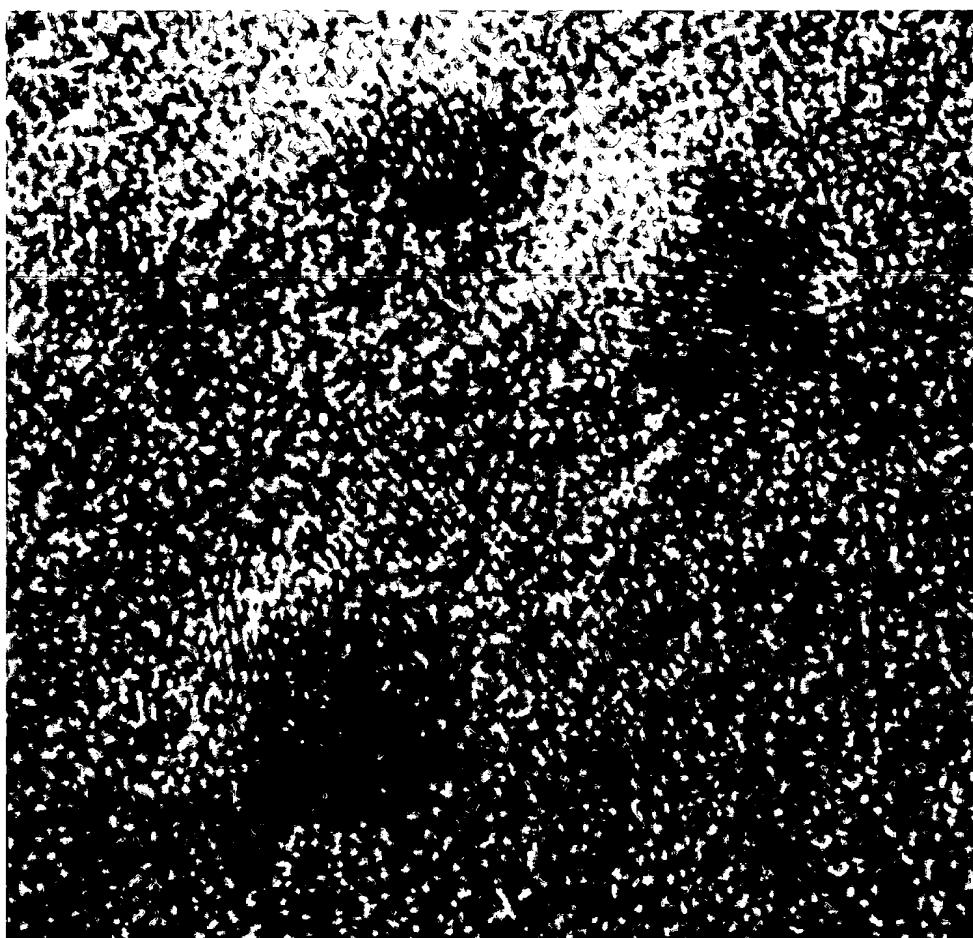


FIG. 8



— 5nm —

FIG. 9

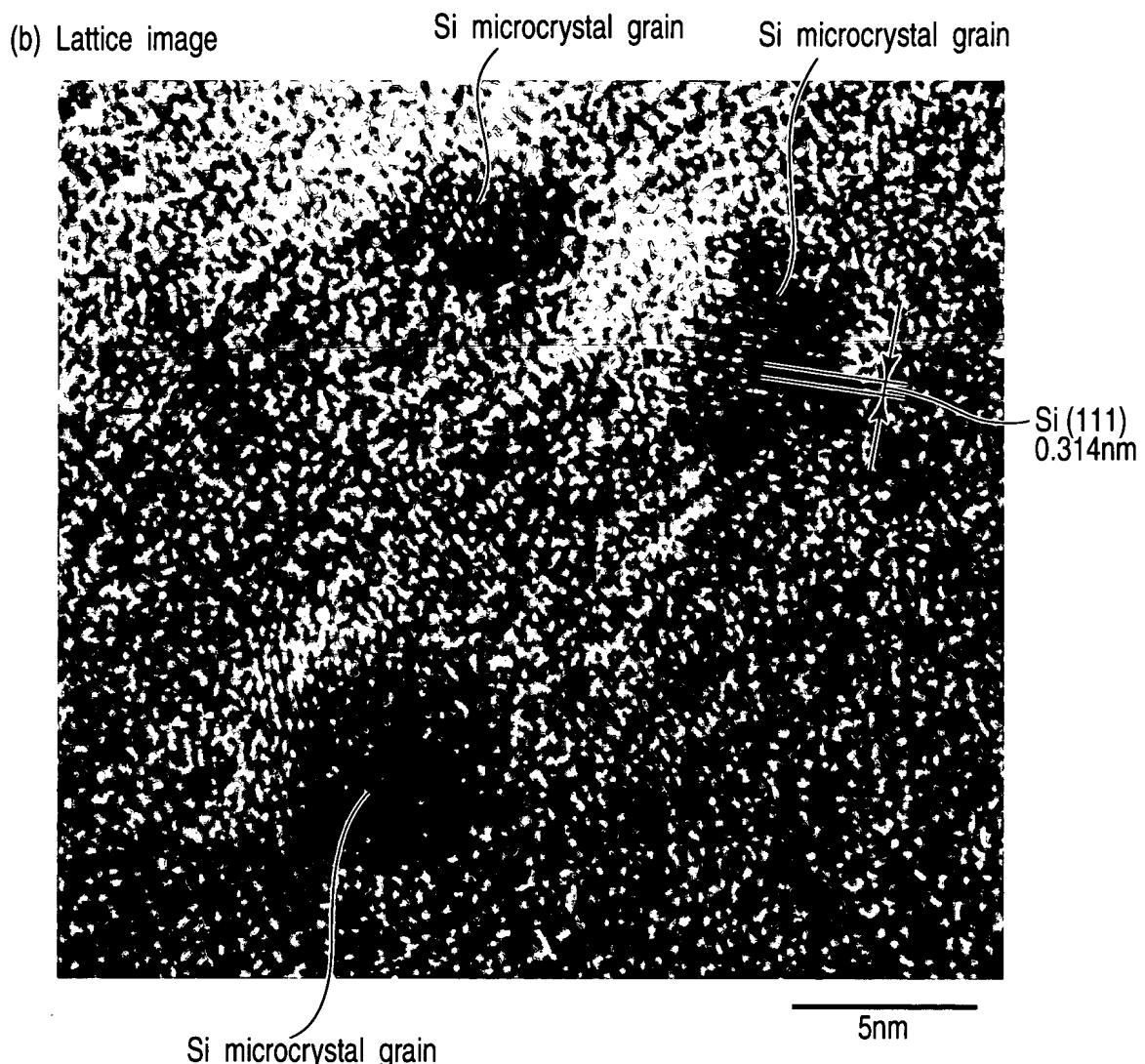


FIG. 10

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FIG. 11